

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Deok-kee Kim et al

Conf. No.: 3513

Serial No.: 10/709,514

Group Art Unit: 1756

Filed: May 11, 2004

Examiner: S. Rosasco

For: METHODS AND STRUCTURES FOR PROTECTING ONE AREA WHILE
PROCESSING ANOTHER AREA ON A CHIP

Commissioner for Patents
United States Patent and Trademark Office
P. O. Box 1450
Alexandria, Virginia 22313-1450

RESPONSE TO REQUIREMENT FOR RESTRICTION

Sir:

In response to the Office Action mailed June 5, 2007, Applicants hereby provisionally elect the invention, as identified by the Examiner, of group II, claims 15 - 24, with traverse, for examination on the merits.

No amendments to the specification, claims or drawings are presented in this paper.

Remarks begin on page 2 of this paper.